

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Nenyai et al.)	Examiner:	Unknown
)		
Serial No: Not Yet Assigned)	Art Unit:	Unknown
)		
Confirmation No: Not Yet Assigned)	Deposit Acct. No:	04-1403
)		
Filed: Herewith)	Customer No:	22827
)		
For: A Process for the Production of a)		
Nitrogenous Layer on a Semiconductor)		
Substrate)		

PRELIMINARY AMENDMENT

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please enter the following Preliminary Amendment in the above captioned application before examining the application on the merits: